



ELECTRONIC COPY

LG801606002
Report verification at igi.org



May 16, 2026

IGI Report Number **LG801606002**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.94 X 6.56 X 4.55 MM**

GRADING RESULTS

Carat Weight **2.59 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

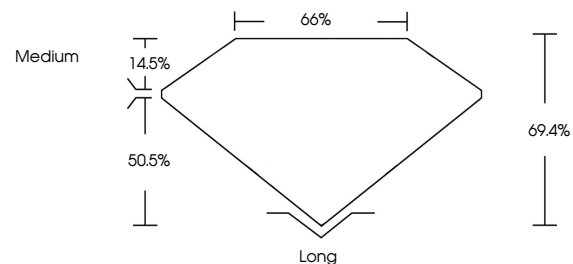
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG801606002**

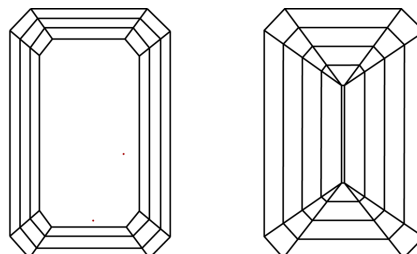
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

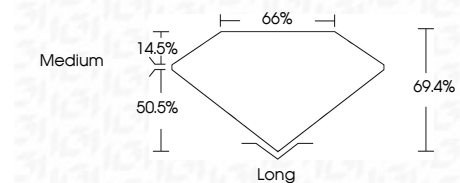
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



May 16, 2026
IGI Report No LG801606002
EMERALD CUT
8.94 X 6.56 X 4.55 MM
2.59 CARATS
Color Grade **F**
Clarity Grade **VVS 2**
Depth **50.5%**
Table **14.5%**
Girdle **Medium**
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG801606002**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa